Anomalous strain relaxation and its impact on the valence-driven spin-state/metal-insulator transition in epitaxial $(Pr_{1-y}Y_y)_{1-y}Ca_xCoO_{3-\delta}$

John E. Dewey ¹, ¹ Supriya Ghosh ¹, ¹ Vipul Chaturvedi ¹, ¹ William M. Postiglione ¹, ¹ Lucca Figari ¹, ¹ Andrew Jacobson, ¹

Caroline Korostynski,¹ Timothy R. Charlton,² K. Andre Mkhoyan⁰,¹ and Chris Leighton⁰,^{*}

¹Department of Chemical Engineering and Materials Science, University of Minnesota, Minneapolis, Minnesota 55455, USA

²Neutron Scattering Division, Oak Ridge National Laboratory, Oak Ridge, Tennessee 37831, USA

(Received 19 December 2022; accepted 2 February 2023; published 22 February 2023)

Pr-based cobaltites exhibit extraordinary phenomena where abrupt valence shifts trigger coupled structural/spin-state/metal-insulator transitions. Recent work achieved strain control of these phenomena in thin films, with epitaxial compression even stabilizing room-temperature transitions. Here, we study the thickness dependence of these effects in the model system compressively strained $YAIO_3(101)/(Pr_{0.85}Y_{0.15})_0$, $Ca_{0.3}CoO_{3-\delta}(001)$. Transport data reveal highly unusual behavior where thicker films exhibit two transitions: one at the fully strained temperature (\sim 245 K) and one near the bulk (\sim 135 K). Highresolution x-ray diffraction confirms that this is due to anomalous strain relaxation where, immediately above the critical thickness (\sim 30 nm), a film region with a near-bulk lattice parameter coexists with a fully strained region. Scanning transmission electron microscopy then reveals striking images where periodic arrays of dislocations occur in the film interior, rather than at the film-substrate interface, seeding accompanying lateral modulations in chemical doping. The unusual transport is thus a direct consequence of anomalous strain relaxation, which we discuss in detail. Intriguing behavior also arises in the ultrathin limit, where temperature-dependent transport and x-ray data reveal gradual suppression of the amplitude of the structural/metal-insulator transition but with no change in transition temperature, which we ascribe to effects of disorder in the presence of symmetry matching between the film and substrate. These results establish an unusual strain relaxation mechanism in perovskite oxide films (likely relevant to other systems) and further elucidate the sensitive strain response of these fascinating and potentially useful valence/structural/spin-state/metal-insulator transitions.

DOI: 10.1103/PhysRevMaterials.7.024415

I. INTRODUCTION

Cobalt-based perovskite and perovskite-related oxides have long been known to exhibit fascinating thermally driven spin-state crossovers. LaCoO₃ is perhaps the archetype, where the d^6 Co³⁺ ions adopt a $t_{2g}^{6}e_g^{0}(S=0)$ configuration at zero temperature (T), due to a crystal field splitting that slightly outweighs the intra-atomic Hund's rule exchange energy [1-8]. This energetic balance is so delicate, however, that occupation of e_g orbitals commences at only ~30 K, inducing thermally excited finite-spin states and paramagnetism, which have been intensively studied [1-8]. Also now well understood, hole doping of LaCoO₃ (e.g., with Sr) generates Co⁴⁺ ions, finite spin states, and eventually, ferromagnetism (e.g., [9-11]). More recently, Pr-containing perovskite cobaltites have been understood to add a further dimension to these spin-state phenomena, through abrupt spin-state transitions, accompanied by coupled structural and metal-insulator transitions. This remarkable phenomenon was initially discovered in $Pr_{0.5}Ca_{0.5}CoO_{3-\delta}$ (PCCO), where, at \sim 90 K, an unusual first-order isomorphic structural transformation takes place, where the *Pnma* cell volume decreases by $\sim 2\%$ on cooling, accompanied by a spin-state transition on the Co^{3+} ions and a metal-insulator transition (MIT) [12,13].

The interest in the above phenomenon was further increased by the realization that it is driven by an unusual mechanism, specifically a first-order Pr valence transition [14–17]. As now confirmed by multiple techniques, the typical Pr³⁺ ions in PCCO and related materials abruptly shift toward Pr⁴⁺ on cooling through the valence transition temperature $(T_{\rm vt})$, triggering a charge-balancing decrease of the mean Co valence and effective doping, thus driving spin-state and metal-insulator transitions [14-25]. This is possible because Pr is essentially the only rare-earth (RE) ion in the RECoO₃ series with 4f electronic states near the Fermi level [26,27]. Model density functional theory calculations on PCCO in fact reproduce the temperature-dependent ionization of Pr via the experimentally observed cell volume collapse [14]. Many open questions remain, however, including the origin of the structural transition, the issue of which (if any) of the several coupled factors primarily drives the transition, and the relation to other known RE valence anomalies, which are of broad interest. The latter include the well-known anomalous valence tendencies of Eu [28], the fact that $PrBa_2Cu_3O_{7-\delta}$ is the sole nonsuperconducting member of the REBa₂Cu₃O_{7- δ} series (which is insulating due to Pr-O hybridization) [29,30], the unusual role played by Pr-O bonding in $Pr_{0.5}Sr_{0.5}CoO_{3-\delta}$ [31], and the likely related T-dependent valence transitions in compounds such as SmS [32].

While the above is fascinating and realizes potentially useful transitions in RE and Co valence, coupled to

^{*}leighton@umn.edu

structural/spin-state/metal-insulator transitions, it must be emphasized that, in bulk Pr cobaltites, these are cryogenic phenomena. The $T_{\rm vt}$ of 90 K in PCCO [12] can be increased by partial substitution of smaller-radii ions for Pr (e.g., Y, Tb, Sm, and Gd [19-22,25,33-36]), i.e., by favoring the low-T collapsed cell volume state with chemical pressure, but solubility limits and oxygen vacancy (V₀) formation limit this approach [22,25,34]. For example, $T_{\rm vt}$ reaches ~135 K in $(Pr_{0.85}Y_{0.15})_{0.7}Ca_{0.3}CoO_{3-\delta}$ [25], a composition we hereafter denote PYCCO. Our recent work changed this status quo through a full study of the tuning of the PY-CCO model system via heteroepitaxial strain [37]. Depositing ~10-nm-thick (25-30 unit cells (u.c.)) epitaxial PYCCO films on a range of substrates [imposing from -2.1%strain (compressive) to +2.3% strain (tensile)] led to complete control over the electronic ground state, from nonmagnetic insulator under compression to ferromagnetic metal under tension [37]. Most significantly, $T_{\rm vt}$ increased rapidly with compressive strain, reaching 245 K in $YAIO_3(101)/(Pr_{0.85}Y_{0.15})_{0.7}Ca_{0.3}CoO_{3-\delta}$ and 291 K in YAlO₃(101)/(Pr_{0.75}Y_{0.25})_{0.7}Ca_{0.3}CoO_{3- δ} (at approximately -2% strain) [37]. This constitutes stabilization of a structural/spin-state/metal-insulator transition system to ambient temperature, perhaps more importantly affording roomtemperature control over a valence transition in a strain-tuned

vice applications [37]. Significantly, the above study focused almost exclusively on \sim 10-nm-thick (25–30 u.c.) PYCCO films, in the fully strained, pseudomorphic regime [37]. Studying the thickness (t) dependence of these phenomena in this model system would be of clear interest, however, particularly on the $\sim 2\%$ compressive YAlO₃ (YAO) substrate that generates the largest $T_{\rm vt}$ [37]. Probing the evolution of the valence/structural/spinstate/metal-insulator transition with strain relaxation at higher t could enable quasicontinuous variation of the cell volume, for example, as opposed to the discrete strains imposed by pseudomorphic heteroepitaxy on various substrates [38-41]. Conversely, probing PYCCO films in the ultrathin limit would also be of interest, due to the wealth of interesting phenomena known to arise in perovskite oxides in this regime, including dead-layer formation [42–44], dimensional confinement [42,45,46], and effects of interfaces/surfaces on structural transitions [47].

perovskite oxide, with broad implications, including for de-

Here, we thus present a t-dependent study of YAO/PYCCO films (2.1% compressive strain), focusing on the most extensively investigated (Pr_{0.85}Y_{0.15})_{0.7}Ca_{0.3}CoO_{3-δ} composition [20-22,25,34]. Epitaxial growth is combined with highresolution x-ray diffraction (HRXRD) [including reciprocal space maps (RSMs)], grazing-incidence x-ray reflectivity (GIXR), atomic force microscopy (AFM), scanning transmission electron microscopy (STEM) with energy-dispersive x-ray spectroscopy (EDX), and T-dependent transport and HRXRD, to provide a detailed view. Transport measurements reveal unusual behavior, where, above a critical thickness $(t_{\rm crit})$ of ~30 nm, two transitions occur, one at the $T_{\rm vt}$ of fully strained films (~245 K) and one close to bulk $T_{\rm vt}$ (~135 K). HRXRD confirms that this is due to anomalous strain relaxation, where, immediately above t_{crit} , PYCCO films exhibit fully strained regions coexisting with near-fully relaxed regions. STEM imaging reveals that this is associated with a periodic array of dislocations occurring ~20 nm from the film-substrate interface, with accompanying lateral chemical doping modulations, establishing an unusual strain relaxation mechanism. Similarly interesting phenomena occur in the low t limit [below ~4 nm (~10 u.c.)], where the structural and metal-insulator transitions are progressively suppressed in amplitude but with no variation in $T_{\rm vt}$, which we ascribe to effects of disorder in the presence of symmetry matching between the film and substrate. Thus, in this paper, we significantly elucidate thickness and strain effects in this ambient-temperature valence transition system, additionally uncovering an unusual strain relaxation mechanism in perovskite oxides, with broad potential relevance.

II. EXPERIMENTAL DETAILS

Polycrystalline $(Pr_{0.85}Y_{0.15})_{0.7}Ca_{0.3}CoO_{3-\delta}$ sputtering targets (2" diameter) were synthesized by solid-state reaction, cold pressing, and sintering of stoichiometric mixtures of Pr_6O_{11} , Y_2O_3 , $CaCO_3$, and Co_3O_4 powders, as reported previously [25,37]. These targets were then used for high-pressure-oxygen sputter deposition of PYCCO films between 1.8 nm (~5 u.c.) and 150 nm (~390 u.c.) thickness, at similar conditions to prior work on La_{1-x}Sr_xCoO_{3-\delta} [48–50]. Briefly, YAO(101) substrates were annealed at 900 °C in 0.45 Torr of flowing ultrahigh-purity O₂ (99.998%) for 15 min prior to growth. Deposition then took place at 600 °C substrate temperature, ~30 W of DC sputter power, and 1.4 Torr of flowing O₂, yielding ~4.1 Å min⁻¹ growth rates; post growth, the films were cooled to ambient temperature in 600 Torr of O₂ at ~15 °C/ min.

Film thicknesses, densities, and roughnesses were determined by GIXR using a Rigaku SmartLab XE diffractometer with Cu $K\alpha$ ($\lambda = 1.5406$ Å) radiation. GenX software [51] was used to fit x-ray reflectivity data, enabling extraction of scattering length density depth profiles. Surface morphology and roughness were additionally studied by AFM using a Bruker Nanoscope V Multimode 8 in contact mode. Film microstructures and lattice parameters were probed by HRXRD, in specular and reciprocal space mapping modes, in a Rigaku SmartLab XE. For T-dependent measurements (130–330 K), the Rigaku SmartLab XE was equipped with an Anton Paar DCS 500 graphite-dome cooling stage and liquid-N₂-flow cryocooler. Cross-section samples for STEM studies were prepared with an FEI Helios Nanolab G4 dual-beam focused ion beam (FIB) system. Samples were first coated with amorphous carbon prior to sectioning in the FIB to prevent damage on exposure to the ion beam. Thinning of the crosssection was done using a 30 keV Ga ion beam followed by a final 2 keV ion beam shower to remove damaged and amorphous surface layers. High-angle annular dark field (HAADF) STEM imaging and EDX spectroscopy were performed on an aberration-corrected FEI Titan G2 60-300 (S)TEM, equipped with a CEOS DCOR probe corrector and a Super-X EDX spectrometer. The microscope was operated at 200 keV with a probe current of 140 pA. A probe convergence angle of 25.5 mrad with detector inner and outer angles of 55 and 200 mrad, respectively, were used for HAADF-STEM. STEM-EDX



FIG. 1. Temperature (*T*) dependence of the resistivity (ρ) (top panels, \log_{10} scale, taken on warming) and corresponding Zabrodskii plots [52] (bottom panels, $\ln W$ vs $\ln T$, where $W = -d \ln \rho/d \ln T$) of 2- to 150-nm-thick films. The data are divided into (a) and (c) $t \ge 9$ nm and (b) and (d) $t \le 9$ nm regimes for clarity. A bulk polycrystalline sample of the same composition is shown for reference in all panels (blue dotted line).

elemental maps were acquired using the Bruker Esprit software with live drift correction. DC electronic transport measurements were performed in a Quantum Design Physical Property Measurement System from 5 to 300 K, using a Keithley 2400 source-measure unit. A four-terminal van der Pauw geometry was employed, with either In or sputtered Mg/Pt contacts, carefully selecting excitation currents to avoid nonohmicity and/or self-heating.

III. RESULTS AND DISCUSSION

A. Thickness-dependent transport properties

We focus first, in Fig. 1, on the *T*-dependent electrical resistivity (ρ) of YAO/PYCCO films as a function of *t*. For clarity, this is split into $t \ge 9$ nm and $t \le 9$ nm regimes in Figs. 1(a) and 1(c) and Figs. 1(b) and 1(d), respectively. For reference, both Figs. 1(a) and 1(b) also show the behavior of bulk polycrystalline PYCCO at this composition (blue dotted lines), where the MIT occurs on cooling below $T_{vt} \approx 135$ K and the resistivity becomes unmeasurably large below ~ 30 K. The exact position of T_{vt} is better determined by derivative analysis, such as the Zabrodskii plots in Figs. 1(c) and 1(d). These plot W vs T on a ln-ln plot, where $W = -d \ln \rho/d \ln T$

is essentially a reduced activation energy [52]. On such plots, the MIT appears as a clear maximum [blue dotted lines in Figs. 1(c) and 1(d)], accurately determining $T_{\rm vt}$. Moving to films, and starting with the high-t regime, Figs. 1(a) and 1(c)show the first striking result of this paper. At t = 9 nm, identical behavior to our recent report [37] is observed, $T_{\rm vt}$ on these YAO substrates (-2.1% strain) being promoted to 245 K [the peak in the red curve in Fig. 1(c)]. Data on cooling/warming (not shown here, see [37]) reveal weak hysteresis, confirming that the first-order nature of the bulk transition is retained. As t is increased to 35 nm, however, the MIT becomes increasingly smeared, as evident in both Figs. 1(a) and 1(c). At higher t, surprising behavior then emerges, with clear evidence of two successive transitions. This is already visible in the 58 and 150 nm curves in Fig. 1(a) but becomes obvious in the high-t curves in Fig. 1(c), where a relatively sharp peak occurs at \sim 245 K, along with a much broader peak at a lower T, the center of which decreases from 180 to ~ 100 K as t increases from 44 to 150 nm. The significance of these temperatures is readily apparent: 245 K is the fully strained $T_{\rm vt}$ [37], while ~135 K corresponds to the bulk $T_{\rm vt}$ [25]. This immediately suggests coexistence of two film regions above $t_{\rm crit} \approx 30$ nm, one with the fully strained $T_{\rm vt}$ and one with close to bulk T_{vt} . This is clearly inconsistent with typical strain relaxation, where, above t_{crit} , the entire film would be expected to progressively strain relax [53–57], in stark contrast to coexistence of strained and near-fully relaxed regions. While we focus in this paper on the *t*-dependent T_{vt} and the strain relaxation that drives it, as an aside, note that the low-*T* resistivity also evolves interestingly with *t*; this is related to phase coexistence with the ferromagnetic metallic phase on the compressive side of the strain phase diagram, which will be the focus of later work.

Figures 1(b) and 1(d) focus on the low-t regime, which also reveals intriguing behavior. In this case, decreasing t from 9 to 4 nm has only minimal impact, specifically a minor increase in the width of the MIT [best seen in Fig. 1(d)]. Further decrease to 3 nm (\sim 8 u.c.), however, induces a clear change, the MIT broadening substantially, leading to significantly increased $\rho(300 \text{ K})$ [Figs. 1(b) and 1(d)]. At t = 2nm (\sim 5 u.c.), the MIT is then broadened to the point that no clear signature remains, even in Fig. 1(d), resulting in insulating behavior in $\rho(T)$ at all T. In essence, the T-dependent MIT is progressively suppressed and broadened below t =9 nm (particularly <4 nm) but with no change in $T_{\rm vt}$ [see Fig. 1(d)], ultimately destroying the metallicity at 300 K. We note immediately that this is intriguing, as, at such a first-order transition, any t-dependent factor that would favor the low-T/low-cell-volume/low-spin/insulating phase over the high-T/high-cell-volume/finite-spin/metallic phase (or vice versa) would naturally shift T_{vt} . If the low-T insulating phase were favored at low thickness, for example, this would drive up $T_{\rm vt}$ and eventually generate insulating behavior at 300 K. This is not what occurs in Figs. 1(b) and 1(d), however, where the onset of 300-K insulating behavior in the low-t limit is instead associated with smearing of the MIT, i.e., lowering of the change in ρ at the transition, with no change in $T_{\rm vt}$.

The key findings from Fig. 1 are distilled into the *t* dependence of four key parameters in Fig. 2: (a) T_{vt} , (b) lnW at T_{vt} [i.e., the height of the peaks in Figs. 1(c) and 1(d)], (c) the width (w_{vt}) of the transition [i.e., the width of the peaks in Figs. 1(c) and 1(d)], and (d) ρ (300 K). The first three of these are obtained by fitting the peaks in Figs. 1(c) and 1(d) (see Supplemental Material Fig. S1 [58] for fits) to a skewed Gaussian [59]:

$$\ln W = a + b \exp\left\{-\ln 2\left[\frac{\ln\left(1 + 2c\left[\frac{\ln T - \ln T_{vt}}{w_{vt}}\right]\right)}{c}\right]^2\right\}, \quad (1)$$

where *a*, *b*, and *c* are constants describing the peak height and asymmetry, T_{vt} is the valence transition temperature, and w_{vt} is the transition width. In the higher–t (≥ 9 nm) regime, Figs. 2(a)–2(c) show the clear splitting of the single transition into two components above $t_{crit} \approx 30$ nm (vertical red dashed line), which we label as strained and relaxed. Above t_{crit} , Fig. 2(a) shows the *t* independence of the fully strained T_{vt} at 245 K, while the relaxed T_{vt} rapidly drops, eventually crossing the bulk value (135 K, horizontal black dashed line) at the highest *t* (note the break on the *t* axis). Correspondingly, lnW at T_{vt} abruptly drops across t_{crit} , followed by a more gradual decrease at higher *t* [Fig. 2(b)]. As this occurs, w_{vt} remains low (i.e., a sharp transition) for the fully strained component, while w_{vt} is distinctly larger (broader transition)



FIG. 2. Thickness (*t*) dependence of (a) the transition temperature (T_{vt}), (b) the transition amplitude (ln *W* at T_{vt} , where $W = -d \ln \rho/d \ln T$), (c) the width of the transition (w_{vt}), and (d) the 300-K resistivity (ρ). As discussed in the text, T_{vt} , ln *W* at T_{vt} , and w_{vt} are determined by fitting skewed Gaussians to Zabrodskii plots [Figs. 1(c) and 1(d)]. See Supplemental Material Fig. S1 [58] for fits. In (a)–(c), black solid points and open blue points are for strained and relaxed components, respectively. Horizontal black dashed lines mark bulk polycrystalline values at this composition, while the vertical red dashed lines mark the crossover to the ultrathin-limit (below ~3.5 nm) and the critical thickness for strain relaxation (~30 nm). Note the breaks on the *t* and $\rho(300 \text{ K})$ axes.

for the relaxed component [Fig. 2(c)]. As all of this higher-*t* evolution takes place, $\rho(300 \text{ K})$ [Fig. 2(d)] remains essentially constant, i.e., the high-*T* metallic state is unaffected. In terms of the low-*t* regime, Fig. 2(a) confirms that T_{vt} is entirely unaffected by thickness reduction, while the transition amplitude [Fig. 2(b)] and width [Fig. 2(c)] rapidly decrease and increase, respectively. Correspondingly, $\rho(300 \text{ K})$ then increases quickly below ~4 nm (~10 u.c.). These trends reflect the smearing of the MIT as *t* is decreased [Fig. 1(d)], eventually resulting in insulating behavior at 300 K [Fig. 1(b)].



FIG. 3. (a) Specular high-resolution x-ray diffraction scans around the pseudocubic 002 film and substrate peaks of 3- to 150-nm-thick films (\log_{10} scale). The scans are vertically offset for clarity and labeled (left) with their thickness (*t*); substrate and film peaks are labeled. (b)–(d) Asymmetric x-ray reciprocal space maps around the pseudocubic 013 film peaks of 9-, 58-, and ~150-nm-thick films. In (a), black dashed lines are guides to the eye illustrating the strain relaxation with increasing thickness. In (b)–(d), bulk (relaxed) positions are marked with a red ×, while the vertical black dashed lines correspond to full strain, i.e., pseudomorphic growth. In all cases, substrate (pseudocubic) reciprocal lattice units (r.l.u.) are used.

B. Anomalous strain relaxation: Experimental characterization

To elucidate the origins of the key phenomena in Figs. 1 and 2, i.e., the existence of two distinct transitions above $t_{\rm crit}$ and the suppression of the MIT with no change in $T_{\rm vt}$ below ~ 4 nm, we turn to *t*-dependent structural characterization. Shown in Fig. 3(a) are *t*-dependent specular HRXRD data around the YAO 002_{pc} (pc = pseudocubic) and PYCCO 002_{pc} reflections. As expected, at $t < t_{crit}$ (~30 nm), the film 002 reflections occur at identical values of Q_z [the z component of the scattering wave vector (in substrate reciprocal lattice units)], consistent with fully strained (compressive), pseudomorphic growth [37]. The only effect of reducing t in this regime is to broaden the primary peaks and progressively space the Laue fringes. At $t > t_{crit}$, however, the Laue fringes vanish, and the primary film peak clearly splits into two. The relative intensity of the peak at the fully strained position gradually decreases with t, while the relative intensity at the higher Q_{z} position increases. The latter peaks correspond to reduced *c*-axis lattice parameters, as would be expected after strain relaxation of compressively strained films. These issues are probed more directly in Figs. 3(b)-3(d), which are asymmetric RSMs around the 013_{pc} reflections of YAO and PYCCO, at t = 9, 58, and 150 nm. At 9 nm [Fig. 3(b)], the behavior is as expected, the film and substrate reflections occurring at identical Q_y (the y component of the scattering wave vector), confirming identical in-plane lattice parameters, i.e., full strain [37]. The film peak at this t is heavily streaked along Q_z due to finite size. At t = 58 and 150 nm, however [Figs. 3(c) and 3(d)], the film reflection is clearly split into two components, one fixed at the fully strained position, while the other rapidly shifts toward the expected bulk position (red ×) [37]. Consistent with Fig. 3(a), there is no gradual shift of a single peak (even an asymmetric one) from the fully strained to fully relaxed locations but instead clear splitting into two lobes. This is in stark contrast to typical strain relaxation [53–57], indicating that even just above t_{crit} , a fully strained film region coexists with a region with near-bulk lattice parameter.

The key results from Fig. 3 are summarized in Fig. 4, which shows the t dependence of (a) the c-axis lattice parameter, (b) the Scherrer length normalized by thickness (Λ/t) , and (c) the relative intensities of the fully strained (left axis) and relaxed (right axis) peaks. The values in Fig. 4(a) were determined from peak positions in Fig. 3(a), the values in Fig. 4(b)from application of the Scherrer equation to peak widths in Fig. 3(a), and the values in Fig. 4(c) from, e.g., $I_{\text{strained}} =$ $I_{\text{strained, peak}}/(I_{\text{strained, peak}} + I_{\text{relaxed, peak}})$, where the *I* values are respective intensities. The anomalous strain relaxation is readily apparent in Fig. 4. As t is increased above t_{crit} (vertical red dashed line), one peak remains at the fully strained location, while the other rapidly approaches the bulk position [Fig. 4(a)], both peaks broaden [shrinking Λ/t , Fig. 4(b)], and there is a gradual transfer of intensity from the fully strained to relaxed peaks [Fig. 4(c)]. These trends indicate that, above t_{crit}, these YAO/PYCCO films abruptly evolve to a situation where a fully strained region (confirmed below to be near the interface with the substrate) coexists with a near-fully relaxed region (confirmed below to be near the surface), further increase in t leading to growth of $I_{relaxed}$ relative to $I_{strained}$.



FIG. 4. Thickness (*t*) dependence of (a) the out-of-plane lattice parameter (*c*), (b) the Scherrer length normalized to the thickness (Λ/t), and (c) the normalized x-ray diffraction intensities of the strained (I_{strained} , left axis) and relaxed (I_{relaxed} , right axis) components. In (a), the bulk polycrystalline value is shown as the horizontal black dashed line, while the green dashed line marks the expected fully strained value based on a Poisson ratio (ν) of $\frac{1}{3}$, as is typical in cobaltites [48,49,60,61]. In (c), the intensities are normalized to the sum of strained and relaxed peak intensities, e.g., $I_{\text{strained}} = I_{\text{strained,peak}}/(I_{\text{strained,peak}} + I_{\text{relaxed,peak}})$. In all panels, black solid points and open blue points are for strained and relaxed components, respectively, and the vertical red dashed line marks the critical thickness for strain relaxation (~30 nm). Note the break on the *t* axis, as in Fig. 2.

Again, this is in clear contrast to standard strain relaxation involving a gradual evolution of a single film peak from the fully strained to fully relaxed positions [53-57,62-64], as observed in a wealth of heteroepitaxial perovskite oxides [65-70]. Most importantly, these data clearly show that the unusual splitting of the *T*-dependent MIT into two distinct transitions in Figs. 1 and 2 is rooted in the anomalous strain relaxation shown in Figs. 3 and 4.

To further probe this unusual strain relaxation, crosssectional STEM imaging was performed on films with $t > t_{crit}$. Figure 5(a) shows a wide-field-of-view low-magnification HAADF image of a 58-nm-thick PYCCO film on YAO. The image is striking: a near-periodic array of dark-contrast regions appear as vertical stripes, beginning not at the filmsubstrate interface but instead at a specific depth in the film interior. The lateral period of these features averages to ~18 nm, corresponding perfectly to $a_{pc}/|\varepsilon_{xx}| = 18$ nm, where a_{pc} is the bulk pseudocubic lattice parameter (3.777 Å) and $|\varepsilon_{xx}|$ is the magnitude of the in-plane epitaxial strain ($\sim 2.1\%$). This suggests that the periodic features in Fig. 5(a) are edge dislocations with Burgers vector magnitude $|\underline{b}| = a_{pc}$, as confirmed by the higher-magnification images in Fig. 5(b). The main panel in Fig. 5(b) shows that edge dislocations are present in the center of the dark stripe regions, while the atomicresolution image in the inset to Fig. 5(b) (from the red boxed region) yields $|\underline{b}| = 3.8$ Å. This is exactly as expected if the dislocation array in Figs. 5(a) and 5(b) enables full strain relaxation in the upper region of the film, consistent with the HRXRD findings from Figs. 3 and 4. In other words, half-planes of missing unit cells occur laterally every ~ 18 nm in the top region of the film. Also consistent with HRXRD, the lower region of the film appears fully strained and nominally defect free, with an apparently sharp interface with the YAO. These observations also explain Fig. 4(b), i.e., that neither film component achieves the Λ expected of a single film coherent throughout its thickness. A more quantitative view of the evolution of the microstructure with depth is provided in Fig. 5(c), which shows the lateral variation of the HAADF intensity (averaged over 3-nm-wide bands) at distances from the substrate-film interface (d) of 3, 8, 15, 22, 31, 39, and 47 nm [as color-coded on the left of Fig. 5(b)]. The HAADF line scans evolve from essentially flat for $d \leq 15$ nm, to clearly modulated with a lateral period of ~ 18 nm at the highest d, the intensity minima corresponding to the dislocation half-planes. Significantly, the onset of modulation occurs at \sim 22 nm, becoming clear at 31–39 nm, i.e., close to 30 nm (i.e., t_{crit}) from the substrate-film interface.

STEM-EDX analysis (Fig. 6) reveals that the strainrelaxing dislocation array in Fig. 5 is also associated with chemical modulation. A wide-scale view of this is provided in Fig. 6(a), which shows EDX elemental maps of Pr, Y, and Ca along with a corresponding HAADF image. The bottom region of the film is chemically homogeneous at this scale. As emphasized by the orange arrows, however, the periodic dislocation half-planes in the top region of the film are systematically poor in Pr and rich in Ca, indicating that Ca dopant ions segregate to the dislocations. This is quantified in Figs. 6(b) and 6(c), which show lateral line scans of the HAADF intensity, and Pr, Y, and Ca concentrations, at the depths labeled 1 and 2, respectively, in Fig. 6(a). At point 1 (the bottom, strained film region), the HAADF intensity and Pr, Y, and Ca concentrations are essentially uniform [Fig. 6(b)]. At point 2, however (the top film region), the HAADF intensity systematically decreases around each dislocation half-plane [the vertical gray bands in Fig. 6(c)]. Correspondingly, the Pr concentration drops periodically at these points, while the Ca concentration peaks. Figure 6(d)illustrates this at the atomic level, where a clear region of dark contrast arises in the central region of the image, corresponding to the half-plane of missing unit cells. The red boxed region on the left in Fig. 6(d) is shown in the center panel at atomic resolution, the right panel [Fig. 6(e)] illustrating the dip in HAADF intensity at the dislocation half-plane, with the associated minimum (maximum) in the Pr (Ca) concentration. In films with $t > t_{crit}$, this Ca enrichment near the dislocation half-planes must of course decrease the average Ca doping



FIG. 5. (a) Low-magnification high-angle annular dark field (HAADF) scanning transmission electron microscopy (STEM) image of a 58-nm-thick film in cross-section along [010]. Periodic HAADF intensity variations are observed in the top region of the film with an average lateral period of 18 nm. The scale bar is 20 nm. (b) Higher-magnification HAADF-STEM image of a section from (a), with an edge dislocation marked. The scale bar is 10 nm. Inset: Atomic-resolution image of the dislocation in (b), with a Burgers circuit shown (orange trace). (c) HAADF intensity lateral line scans across the film section in (b). The colors correspond to the distances from the film-substrate interface (*d*) shown in (b). The intensity was integrated over a band of height 3 nm.

in the remainder of the film, potentially contributing to the highest *t* decrease in T_{vt} (to below the bulk value) in Fig. 2(a), as T_{vt} decreases at sufficiently low *x* in these compounds [33]. The associated inhomogeneity in Ca doping also explains the highest *t* increase in w_{vt} in Fig. 2(c), i.e., the transition broadening.

Some of the key thickness- and depth-dependent trends from HRXRD and STEM/EDX also manifest in GIXR, as shown in Figs. 7(a) and 7(b). Figure 7(a) plots the specular x-ray reflectivity (R) from films with various t, scaled by the Fresnel reflectivity, as is common [62]. The latter is proportional to Q_z^{-4} , where Q_z is the z component of the scattering wave vector. At t = 5 and 9 nm, RQ_z^4 is approximately flat above the critical angle, aside from the expected Kiessig oscillations, which decrease in spacing as t is increased. A clear change in behavior occurs at 30 nm ($\sim t_{crit}$) and above, however, where RQ_z^4 develops a prominent kink at $Q_z \approx 0.2 \text{ Å}^{-1}$, and the amplitudes of the Kiessig fringes are significantly damped. Quantitatively, the red/black solid lines through the data in Fig. 7(a) show that the reflectivity below t_{crit} can be well fit with a simple single-layer model. The resulting real and imaginary parts of the x-ray scattering length density (SLD) are shown vs depth in Fig. 7(b), with the full set of model parameters shown in Supplemental Material Table S1 [58]. For t = 5, 9, and 25 nm, the fits are achieved with SLDs within 1-5% of the ideal bulk value for PYCCO [horizontal dashed lines in Fig. 7(b)], and interface/surface roughnesses <0.5 nm, i.e., the single-unit-cell level. Above $t_{\rm crit}$, however, single-layer fits failed to reproduce the data, even qualitatively. Instead, a two-layer model was required (see Supplemental Material Table S1 [58] for detailed parameters), resulting in the distinctly different depth profiles shown in Fig. 7(b). The essential differences in the higher t regime are (i) a substantially rougher top surface, which the two-layer model accommodates (note the more gradual drop-off in SLD at the surface, and the associated parameters in Supplemental Material Table S1 [58]) and (ii) monotonically increasing substrate-film roughness, possibly indicating increased interdiffusion (e.g., of Y) at higher growth times. Most importantly, the top surface roughening we deduce is consistent with STEM images [e.g., Fig. 5(a)], which show periodic surface corrugation driven by the periodic dislocation array that forms at $t > t_{crit}$, also consistent with the loss of Laue fringes above t_{crit} in HRXRD [Fig. 3(a)].

A final piece of structural characterization is provided in Figs. 7(c)-7(e), which show AFM images and analysis



FIG. 6. (a) Cross-sectional high-angle annular dark field (HAADF) image (along [010]), along with corresponding energy-dispersive x-ray spectroscopy (EDX) maps of the Pr, Y, and Ca concentration (atomic %), for the same film as in Fig. 5. Dislocations are labeled with orange arrows, and the scale bar is 20 nm. (b) and (c) Lateral line scans of HAADF intensity and Pr, Y, and Ca concentration (in at. %) from the depths labeled 1 and 2 in (a). Intensities/concentrations were integrated over bands of height (b) 6.8 nm and (c) 10.5 nm. (d) Atomic-resolution HAADF image (10-nm scale bar) focused on the area above a single dislocation (red boxed region). (e) Integrated HAADF intensity and corresponding lateral at. % concentration profiles of Pr, Y, and Ca from the magnified panel in (d).

of films above and below t_{crit} . At t = 8 nm [Fig. 7(c)], flat terraces and unit-cell-high steps are found, yielding root-mean-square (RMS) roughness of only 0.15 nm, quite consistent with GIXR (Supplemental Material Table S1 [58]). At $t \approx 150$ nm, however (i.e., far above t_{crit}), island formation becomes clear in Fig. 7(d), generating a higher RMS roughness of 0.95 nm, and a lateral correlation length of 22 nm. This is in good agreement with both GIXR (Fig. 7(b), Supplemental Material Table S1 [58]) and STEM [Fig. 5(a)], further confirming the corrugation of the top surface with a lateral period ~20 nm when $t > t_{crit}$, associated with the periodic dislocation array. The two AFM height (*z*) scans in Fig. 7(e), from the lines indicated by the arrows in Figs. 7(c) and 7(d), reinforce this point.

C. Anomalous strain relaxation: Discussion

The above transport and structural/chemical characterization data generate a clear picture of the strain relaxation in these compressively strained YAO/PYCCO films. As the t_{crit} of ~30 nm is exceeded, almost immediately, a near-fully relaxed upper film region coexists with a fully strained lower region. The lower region is nominally chemically uniform and defect free, while the upper region hosts a near-periodic array of dislocations that form in the film interior, relaxing strain and generating lateral modulations in chemical composition (primarily Pr/Ca doping) and surface roughness. As a first point in discussing this strain relaxation, it is instructive to highlight the key differences between these observations and the classic strain relaxation mechanism of Matthews and



FIG. 7. (a) Specular grazing-incidence x-ray reflectivity (*R*), normalized to the Fresnel reflectivity (which is proportional to Q_z^{-4} , where Q_z is the *z* component of the scattering wave vector), for 5- to 58-nm-thick films [the thickness (*t*) is labeled to the right]. Scans are vertically offset for clarity. Corresponding fits (red or black solid lines) are shown for all *t*. (b) Scattering length density (SLD) vs depth (*z*), as refined from the x-ray reflectometry data in (a). Real and imaginary components of the SLD are shown on opposing (i.e., positive and negative, respectively) vertical axes. Simulated SLD profiles for $t \leq 25$ nm (i.e., below the critical thickness for strain relaxation) employ a single-layer model, while thicker films employ a two-layer model. The bulk real and imaginary SLD values for PYCCO are indicated by the black dashed horizontal lines, while the same bulk values for YAO are indicated by black stars. See Supplemental Material Table S1 [58] for all reflectometry fit parameters. (c) and (d) Atomic force microscopy images $(2 \times 1.5 \,\mu\text{m}^2)$ of (c) an 8-nm-thick film and (d) a 150-nm-thick film. Scale bars are 500 nm. (e) Representative height (*z*) scans from atomic force microscopy (AFM) images, collected along lines indicated by white arrows in (c) and (d).

Blakeslee (MB) [53–55,57,64], as extensively referred to in the literature [63,65–68,70]. In the MB picture, sessile dislocations formed at the film-substrate interface in the initial stages of growth become glissile at t_{crit} , once the resolved shear force exerted by the growing pseudomorphic film exceeds the line tension restraining dislocation motion [55]. Glide then occurs laterally, eventually generating a crisscross pattern of edge dislocations at the film-substrate interface, the density of which fully relaxes strain [55,57,64]. Vitally, in this mechanism, the dislocations thus reach the film-substrate interface, and strain relaxation is triggered throughout the entire film thickness, as observed in numerous heteroepitaxial oxides [71–76]. This is in stark contrast to our findings, as the dislocations in our YAO/PYCCO films occur in the film interior [Figs. 5(a), 5(b), 6(a), etc.], and completely distinct upper (relaxed) and lower (strained) regions emerge (from transport, HRXRD, STEM/EDX, GIXR, and AFM [Figs. 1–7)].

Notably, there exists a modification of the MB mechanism that allows for nucleation of dislocation loops from the growing film surface, particularly via heterogeneous nucleation if the film surface roughens or develops islands [55,77–80]. At first sight, this would appear to be a plausible mechanism for the nucleation of the dislocations we observe, particularly in light of the roughening seen in STEM [Fig. 5(a)], GIXR (Fig. 7(b), Supplemental Material Table S1 [58]), and

AFM [Figs. 7(c)-7(e)]. This model also predicts, however, that the dislocation loops, after formation, glide down to the film-substrate interface, thus relieving strain through the entire thickness [77,78]. This is therefore again in contrast with our observations; in our films, some countervailing force must pin the dislocations in a horizontal plane near t_{crit} [as in Figs. 5(a), 5(b), and 6(a)]. Several other atypical strain relaxation mechanisms have also been documented in heteroepitaxial films of oxides such as perovskites, including mechanisms based on Vo-ordered stripes [48,49,71,81,82], Ruddlesden-Popper faults and similar planar defects [83-87], antiphase and outof-phase boundaries [88], and different forms of (interfacial) dislocation arrays [71,72]. None of these defect types are detected in our YAO/PYCCO films, however, and thus, these mechanisms are also incapable of explaining our observations. In particular, the V_O ordering frequently encountered in perovskite cobaltite thin films [48,49,71,81,82] is not observed here [37]. One thing that is worth noting, however, is that we are aware of at least one potentially related observation in perovskites. Specifically, Catalan et al. [89] reported anomalous changes in the T-dependent MIT in NdGaO₃(001)/NdNiO₃ films at thicknesses exceeding a critical value, reminiscent of the behavior in Figs. 1 and 2. Their NdNiO₃ films at low t exhibited a single peak in $d \ln \rho / dT$ vs T at the MIT, while films with t of 185–550 nm showed a second peak at a temperature closer to bulk [89], analogous to Figs. 1(c) and 2(a). Unfortunately, *t*-dependent structural characterization data for those films was not presented in this *t* range, although the authors did posit strain relaxation into two distinct film components to explain their transport data [89].

The other remarkable feature of the strain relaxation we observe in these YAO/PYCCO films is the associated lateral chemical modulation (Fig. 6). The first point to discuss in this context is that a variety of complex strain-mediated interactions between dislocations and impurity point defects are known in various materials. The Cottrell atmospheres forming in alloys where small (often interstitial) impurity atoms segregate around dislocation cores, thereby generating pinning effects, is a classic example [90,91]. Interestingly, at least one example of this phenomenon has been claimed in perovskite oxides (PbZr_{1-x}Ti_xO₃ [92]). A second point of comparison is encountered in epitaxial films of compound semiconductors (particularly III-V and II-VI semiconductors), where spatially varying strain, differing ionic/atomic radii, and differing ionic/atomic mobility can couple in complex ways, resulting in a spatially periodic composition modulation that effectively relaxes (local) strain during film growth [93–96]. Related phenomena could conceivably be at work in YAO/PYCCO, with chemical segregation occurring to relieve stresses at the dislocation cores and half-planes, particularly given our 600 °C growth temperature and the only ~ 18 nm distance between dislocations. However, our primary observation is of chemical segregation to the dislocation half-planes in the upper film region, on the tensile strain side of the dislocations, which is inconsistent with the smaller radius of Ca^{2+} cf. Pr^{3+} . Moreover, the difference in ionic radii between Pr^{3+} and Ca^{2+} is only ~2% compared with ~9% for Pr^{3+} and Y^{3+} [97], suggesting that any segregation, to any region of the dislocations, would involve Y rather than Ca, counter to our observations. While larger mass and lower diffusivity of Y vs Ca could play a role here, it is likely that the chemical segregation shown in Fig. 6 is thus at least partly charge driven rather than solely strain driven, explaining the role for aliovalent Ca^{2+} over isovalent Y^{3+} . Segregation of charged dopant ions around dislocations is in fact known in heteroepitaxial perovskite oxides, as recently emphasized in dislocation-rich systems such as BaSnO₃ [98]. Finally, we note parenthetically that the temperature-dependent valence changes on Pr and Co ions have not yet taken place in the 300-K images in Fig. 6 and certainly not at the growth temperature, meaning that a role for the valence transition in this process is difficult to imagine.

Summarizing, the unusual thickness evolution of the transport behavior shown in Figs. 1 and 2 is clearly rooted in the anomalous strain relaxation documented in Figs. 3–7. Above $t_{\rm crit}$, YAO/PYCCO films form a lower film region that is nominally chemically homogeneous and defect free. Atop this is an upper region in which a periodic array of edge dislocations occurs mid-film, relaxing strain and generating surface roughening and lateral segregation of Ca²⁺ to the dislocation half-planes. These phenomena cannot be simply explained by MB or modified-MB strain relaxation, wherein dislocations propagate to the substrate-film interface, or to the formation of other extended defects such as V_O-ordered stripes, which are not detected. Instead, some countervailing interaction must pin the strain-relaxation-enabling edge dislocations in a plane ~20 nm from the YAO/PYCCO interface [e.g., Fig. 5(a)].



FIG. 8. Temperature (*T*) dependence of the change in out-ofplane lattice parameter (Δc) from the 260-K value (left axis), and the resistivity (ρ , right axis), of 3- and 11-nm-thick films. Error bars on Δc for the 11-nm-thick film are smaller than the data points. Dashed lines are guides to the eye, indicating the approximate temperature bounds of the valence transition (gray) and the linear thermal expansion regimes above and below the transition (red).

The origin of this interaction is currently unknown, although this phenomenon may well have been sporadically observed in other perovskite oxides (e.g., Ref. [89]). We hope that this paper stimulates additional research in this direction.

D. Ultrathin-limit behavior

Finally, with the anomalous strain relaxation at high tdiscussed in full, we now return to the second striking observation from Figs. 1 and 2: the gradual suppression of the MIT at low t [particularly below $\sim 4 \text{ nm}$ ($\sim 10 \text{ u.c.}$)], with no change in $T_{\rm vt}$. Deeper insight into the origin of this behavior is provided in Fig. 8, which compares the $\rho(T)$ (right axis) of 3- and 11-nm-thick films with corresponding measurements of the change in their *c*-axis lattice parameters $(\Delta c, \text{ left axis})$ from T-dependent HRXRD. Consistent with Sec. I and our recent report [37], the t = 11 nm YAO/PYCCOfilm exhibits a large ($\sim 1.3\%$) c-axis contraction on cooling through $T_{\rm vt}$ (see the red dashed extrapolation lines), with T dependence mirroring $\rho(T)$. At t = 3 nm (8 u.c.), however, where the MIT is smeared substantially (Fig. 8, right axis), resulting in insulating behavior to 300 K, the magnitude of Δc across the structural/valence/spin-state/metal-insulator transition is distinctly reduced (Fig. 8, left axis). The collapse of the c-axis lattice parameter in fact decreases to <1% but maintains a near-identical shape to the t = 11 nm case. The magnitude of the cell volume collapse across the transition is thus suppressed commensurately with the magnitude of the resistivity change at the MIT but with no change in $T_{\rm vt}$. We suspect that this trend continues to lower t, although probing this is challenging due to the difficulty of detecting small T-dependent peak position changes on highly broadened peaks [see the low-t data in Fig. 3(a)]. As already noted, the unusual aspect to this behavior is that the transition is clearly profoundly impacted by t reduction but with no impact on $T_{\rm vt}$ [Figs. 1(b), 1(d), and 8]. Typically, such significant changes would be expected to energetically favor either the low-T (insulating) or high-T (metallic) phases, thereby shifting the temperature at which their free energy curves intersect, altering $T_{\rm vt}$.

The first point to note in discussing the above is that literature precedent for such a phenomenon exists. In SrTiO₃/La_{0.33}Sr_{0.67}FeO₃ films, for example, the Verwey-type T-dependent MIT has been reported to be largely pinned at \sim 190 K but to gradually evolve into featureless insulating $\rho(T)$ in the very thin film limit [99]. Perhaps the simplest idea to explain such behavior would be that increased defects and disorder in the ultrathin limit could drive electronic localization, generating insulatinglike $\rho(T)$ at progressively higher T. Once insulatinglike behavior exceeds $T_{\rm vt}$ (~245 K here), electronic transport could become far less sensitive to the structural/spin-state/valence transition, naturally explaining a reduction in the resistivity change across $T_{\rm vt}$. In our case, however, Fig. 8 establishes that the change in c across $T_{\rm vt}$ commensurately decreases with the change in ρ across $T_{\rm vt}$, indicating continued coupling between structure and transport at the lowest probed t. We propose that a key additional factor here is the symmetry matching between the YAO and PYCCO. Specifically, the substrate space group (Pnma) matches both the high-T and low-T film space group (both are *Pnma* in PYCCO, but with a volume collapse across $T_{\rm vt}$). As established in ultrathin NdNiO₃, for example, such matching of the symmetry between the substrate and the low-T film structure is highly significant, essentially enabling a bulklike transition [100]. Related to this, growth of VO_2 films on symmetry-mismatched substrates like Al₂O₃ and ZnO gives rise to interfacial transition layers with modified MIT behavior [101,102], quite unlike symmetry-matched VO₂ on TiO₂ [103,104]. In our case, we propose that symmetry matching is a key factor that enables a bulklike T_{vt} to persist to low t. At the very lowest t, we then hypothesize that increased defects and disorder eventually broaden the phase coexistence region between the metallic and insulating phases, smearing the transition both in structure (Fig. 8) and transport [Figs. 1(b), 1(d), and 8]. This disorder could arise from the increased influence of interface and surface roughness, as well as additional point defects such as V₀, all of which would be naturally expected in the very low-t limit.

IV. SUMMARY

The results of a detailed thickness-dependent study of compressively strained $YAIO_3(101)/(Pr_{0.85}Y_{0.15})_{0.7}Ca_{0.3}CoO_{3-\delta}(001)$ films have been presented, based primarily

on transport, high-resolution x-ray diffraction, and crosssectional transmission electron microscopy. This material serves as a model system for the strain control of Pr valence transitions. The results reveal an unusual thickness evolution of the temperature-dependent valence-driven structural-spin-state/metal-insulator transition in this system, which can be directly traced to anomalous strain relaxation. In essence, above the critical thickness, a periodic array of misfit dislocations occurs in the $(Pr_{0.85}Y_{0.15})_{0.7}Ca_{0.3}CoO_{3-\delta}$, not at the substrate-film interface but instead in the film interior, accompanied by lateral modulations in chemical composition (particularly Ca doping). This results, even just above the critical thickness, in the coexistence of a fully strained homogeneous lower film region with a near-fully relaxed chemically modulated upper region, establishing an unusual mode of strain relaxation, which we discussed in detail. In the low-thickness limit, the temperature-dependent structural/metal-insulator transition is seen to gradually vanish, with strikingly little change in transition temperature, which we ascribe to effects due to increased disorder in the ultrathin-film limit in the presence of symmetry matching between the film and substrate. These results significantly elucidate the thickness and strain effects in this ambienttemperature valence transition system, also exposing an unusual strain relaxation mechanism in perovskite oxides, of broad potential interest and relevance.

ACKNOWLEDGMENTS

Work at the University of Minnesota (UMN) was primarily supported by the Department of Energy (DOE) through the UMN Center for Quantum Materials under No. DE-SC0016371. Electron microscopy by S.G. and K.A.M. was supported by the National Science Foundation (NSF) through the UMN MRSEC under No. DMR-2011401. Parts of this work were carried out in the Characterization Facility, UMN, which receives partial support from the NSF through the MRSEC program. We thank Michael Fitzsimmons, Richard James, Steven May, and Javier Garcia-Barriocanal for productive discussions.

C.L., J.E.D., and V.C. conceived of the study. J.E.D., V.C., W.M.P., L.F., A.J., and C.K. grew the films and performed the structural characterization, under the supervision of C.L. J.E.D. performed the transport measurements and led the data analysis, under the supervision of C.L. S.G. and K.A.M. performed the electron microscopy and associated analysis. T.R.C. contributed to the analysis of the GIXR data. J.E.D. and C.L. wrote the paper, with input from all authors.

- R. R. Heikes, R. C. Miller, and R. Mazelsky, Magnetic and electrical anomalies in LaCoO₃, Physica 30, 1600 (1964).
- [3] M. A. Korotin, S. Yu. Ezhov, I. V. Solovyev, V. I. Anisimov, D. I. Khomskii, and G. A. Sawatzky, Intermediate-spin state and properties of LaCoO₃, Phys. Rev. B 54, 5309 (1996).
- [4] M. Imada, A. Fujimori, and Y. Tokura, Metal-insulator transitions, Rev. Mod. Phys. 70, 1039 (1998).
- [5] Z. Ropka and R. J. Radwanski, ⁵D term origin of the excited triplet in LaCoO₃, Phys. Rev. B 67, 172401 (2003).
- [6] M. W. Haverkort, Z. Hu, J. C. Cezar, T. Burnus, H. Hartmann, M. Reuther, C. Zobel, T. Lorenz, A. Tanaka, N. B. Brookes *et al.*, Spin State Transition in LaCoO₃ Studied Using

Soft X-Ray Absorption Spectroscopy and Magnetic Circular Dichroism, Phys. Rev. Lett. **97**, 176405 (2006).

- [7] A. Podlesnyak, S. Streule, J. Mesot, M. Medarde, E. Pomjakushina, K. Conder, A. Tanaka, M. W. Haverkort, and D. I. Khomskii, Spin-State Transition in LaCoO₃: Direct Neutron Spectroscopic Evidence of Excited Magnetic States, Phys. Rev. Lett. **97**, 247208 (2006).
- [8] R. F. Klie, J. C. Zheng, Y. Zhu, M. Varela, J. Wu, and C. Leighton, Direct Measurement of the Low-Temperature Spin-State Transition in LaCoO₃, Phys. Rev. Lett. 99, 047203 (2007).
- [9] M. A. Señarıs-Rodriguez and J. B. Goodenough, Magnetic and transport properties of the system La_{1-x}Sr_xCoO_{3- δ}(0 < x \leq 0.50), J. Solid State Chem. **118**, 323 (1995).
- [10] J. Wu and C. Leighton, Glassy ferromagnetism and magnetic phase separation in La_{1-x}Sr_xCoO₃, Phys. Rev. B 67, 174408 (2003).
- [11] P. P. Orth, D. Phelan, J. Zhao, H. Zheng, J. F. Mitchell, C. Leighton, and R. M. Fernandes, Essential role of magnetic frustration in the phase diagrams of doped cobaltites, Phys. Rev. Mater. 6, L071402 (2022).
- [12] S. Tsubouchi, T. Kyômen, M. Itoh, P. Ganguly, M. Oguni, Y. Shimojo, Y. Morii, and Y. Ishii, Simultaneous metal-insulator and spin-state transitions in Pr_{0.5}Ca_{0.5}CoO₃, Phys. Rev. B 66, 052418 (2002).
- [13] S. Tsubouchi, T. Kyômen, M. Itoh, and M. Oguni, Electric, magnetic, and calorimetric properties and phase diagram of $Pr_{1-x}Ca_xCoO_3(0 \le x \le 0.55)$, Phys. Rev. B **69**, 144406 (2004).
- [14] K. Knížek, J. Hejtmánek, P. Novák, and Z. Jirák, Charge transfer, valence, and the metal-insulator transition in Pr_{0.5}Ca_{0.5}CoO₃, Phys. Rev. B 81, 155113 (2010).
- [15] J. L. García-Muñoz, C. Frontera, A. J. Barón-González, S. Valencia, J. Blasco, R. Feyerherm, E. Dudzik, R. Abrudan, and F. Radu, Valence transition in (Pr, Ca)CoO₃ cobaltites: Charge migration at the metal-insulator transition, Phys. Rev. B 84, 045104 (2011).
- [16] J. Herrero-Martín, J. L. García-Muñoz, S. Valencia, C. Frontera, J. Blasco, A. J. Barón-González, G. Subías, R. Abrudan, F. Radu, E. Dudzik *et al.*, Valence change of praseodymium in Pr_{0.5}Ca_{0.5}CoO₃ investigated by x-ray absorption spectroscopy, Phys. Rev. B **84**, 115131 (2011).
- [17] J. Herrero-Martín, J. L. García-Muñoz, K. Kvashnina, E. Gallo, G. Subías, J. A. Alonso, and A. J. Barón-González, Spin-state transition in Pr_{0.5}Ca_{0.5}CoO₃ analyzed by x-ray absorption and emission spectroscopies, Phys. Rev. B 86, 125106 (2012).
- [18] H. Masuda, T. Fujita, T. Miyashita, M. Soda, Y. Yasui, Y. Kobayashi, and M. Sato, Transport and magnetic properties of $R_{1-x}A_x$ CoO₃ (R = La, Pr and Nd; A = Ba, Sr and Ca), J. Phys. Soc. Jpn. **72**, 873 (2003).
- [19] T. Fujita, T. Miyashita, Y. Yasui, Y. Kobayashi, M. Sato, E. Nishibori, M. Sakata, Y. Shimojo, N. Igawa, Y. Ishii *et al.*, Transport and magnetic studies on the spin state transition of Pr_{1-x}Ca_xCoO₃ up to high pressure, J. Phys. Soc. Jpn. **73**, 1987 (2004).
- [20] J. Hejtmánek, E. Šantavá, K. Knížek, M. Maryško, Z. Jirák, T. Naito, H. Sasaki, and H. Fujishiro, Metal-insulator transi-

tion and the Pr^{3+}/Pr^{4+} valence shift in $(Pr_{1-y}Y_y)_{0.7}Ca_{0.3}CoO_3$, Phys. Rev. B **82**, 165107 (2010).

- [21] H. Fujishiro, T. Naito, S. Ogawa, N. Yoshida, K. Nitta, J. Hejtmánek, K. Knížek, and Z. Jirák, Valence shift of Pr ion from 3+ to 4+ in (Pr_{1-y}Y_y)_{0.7}Ca_{0.3}CoO₃ estimated by x-ray absorption spectroscopy, J. Phys. Soc. Jpn. **81**, 064709 (2012).
- [22] J. Hejtmánek, Z. Jirák, O. Kaman, K. Knížek, E. Šantavá, K. Nitta, T. Naito, and H. Fujishiro, Phase transition in Pr_{0.5}Ca_{0.5}CoO₃ and related cobaltites, Eur. Phys. J. B 86, 305 (2013).
- [23] S. El-Khatib, S. Bose, C. He, J. Kuplic, M. Laver, J. A. Borchers, Q. Huang, J. W. Lynn, J. F. Mitchell, and C. Leighton, Spontaneous formation of an exchange-spring composite via magnetic phase separation in Pr_{1-x}Ca_xCoO₃, Phys. Rev. B 82, 100411(R) (2010).
- [24] D. Phelan, Y. Suzuki, S. Wang, A. Huq, and C. Leighton, Structural, transport, and magnetic properties of narrow bandwidth Nd_{1-x}Ca_xCoO_{3- δ} and comparisons to Pr_{1-x}Ca_xCoO_{3- δ}, Phys. Rev. B **88**, 075119 (2013).
- [25] D. Phelan, K. P. Bhatti, M. Taylor, S. Wang, and C. Leighton, Magnetically inhomogeneous ground state below the firstorder valence transition in (Pr_{1-y}Y_y)_{0.7}Ca_{0.3}CoO₃, Phys. Rev. B 89, 184427 (2014).
- [26] J. B. Goodenough, Localized to Itinerant Electronic Transition in Perovskite Oxides (Springer-Verlag, Heidelberg, 2001).
- [27] M. Topsakal, C. Leighton, and R. M. Wentzcovitch, Firstprinciples study of crystal and electronic structure of rare-earth cobaltites, J. Appl. Phys. **119**, 244310 (2016).
- [28] S. Cotton, *Lanthanide and Actinide Chemistry* (Wiley, Chichester, 2006).
- [29] R. Fehrenbacher and T. M. Rice, Unusual Electronic Structure of PrBa₂Cu₃O₇, Phys. Rev. Lett. **70**, 3471 (1993).
- [30] M. Merz, N. Nücker, E. Pellegrin, P. Schweiss, S. Schuppler, M. Kielwein, M. Knupfer, M. S. Golden, J. Fink, C. T. Chen *et al.*, X-ray absorption spectroscopy of detwinned Pr_xY_{1-x}Ba₂Cu₃O_{7-y} single crystals: Electronic structure and hole distribution, Phys. Rev. B 55, 9160 (1997).
- [31] C. Leighton, D. D. Stauffer, Q. Huang, Y. Ren, S. El-Khatib, M. A. Torija, J. Wu, J. W. Lynn, L. Wang, N. A. Frey *et al.*, Coupled structural/magnetocrystalline anisotropy transitions in the doped perovskite cobaltite Pr_{1-x}Sr_xCoO₃, Phys. Rev. B 79, 214420 (2009).
- [32] A. Jayaraman, V. Narayanamurti, E. Bucher, and R. G. Maines, Continuous and Discontinuous Semiconductor-Metal Transition in Samarium Monochalcogenides under Pressure, Phys. Rev. Lett. 25, 1430 (1970).
- [33] T. Fujita, S. Kawabata, M. Sato, N. Kurita, M. Hedo, and Y. Uwatoko, On the mechanism of the spin state transition of (Pr_{1-y}Sm_y)_{1-x}Ca_xCoO₃, J. Phys. Soc. Jpn. 74, 2294 (2005).
- [34] T. Naito, H. Sasaki, and H. Fujishiro, Simultaneous metalinsulator and spin-state transition in $(Pr_{1-y}RE_y)_{1-x}Ca_xCoO_3$ (*RE* = Nd, Sm, Gd, and Y), J. Phys. Soc. Jpn. **79**, 034710 (2010).
- [35] H. Fujishiro, T. Naito, D. Takeda, N. Yoshida, T. Watanabe, K. Nitta, J. Hejtmánek, K. Knížek, and Z. Jirák, Simultaneous valence shift of Pr and Tb ions at the spin-state transition in (Pr_{1-y}Tb_y)_{0.7}Ca_{0.3}CoO₃, Phys. Rev. B **87**, 155153 (2013).
- [36] F. Guillou, Q. Zhang, Z. Hu, C. Y. Kuo, Y. Y. Chin, H. J. Lin, C. T. Chen, A. Tanaka, L. H. Tjeng, and V. Hardy, Coupled

valence and spin state transition in (Pr_{0.7}Sm_{0.3})_{0.7}Ca_{0.3}CoO₃, Phys. Rev. B **87**, 115114 (2013).

- [37] V. Chaturvedi, S. Ghosh, D. Gautreau, W. M. Postiglione, J. E. Dewey, P. Quarterman, P. P. Balakrishnan, B. J. Kirby, H. Zhou, H. Cheng *et al.*, Room-temperature valence transition in a strain-tuned perovskite oxide, Nat. Commun. 13, 7774 (2022).
- [38] D. G. Schlom, L.-Q. Chen, C.-B. Eom, K. M. Rabe, S. K. Streiffer, and J.-M. Triscone, Strain tuning of ferroelectric thin films, Annu. Rev. Mater. Res. 37, 589 (2007).
- [39] D. G. Schlom, L.-Q. Chen, C. J. Fennie, V. Gopalan, D. A. Muller, X. Pan, R. Ramesh, and R. Uecker, Elastic strain engineering of ferroic oxides, MRS Bull. 39, 118 (2014).
- [40] S. Middey, J. Chakhalian, P. Mahadevan, J. W. Freeland, A. J. Millis, and D. D. Sarma, Physics of ultrathin films and heterostructures of rare-earth nickelates, Annu. Rev. Mater. Res. 46, 305 (2016).
- [41] S. Catalano, M. Gibert, J. Fowlie, J. Íñiguez, J.-M. Triscone, and J. Kreisel, Rare-earth nickelates RNiO₃: Thin films and heterostructures, Rep. Prog. Phys. 81, 046501 (2018).
- [42] A. Bhattacharya and S. J. May, Magnetic oxide heterostructures, Annu. Rev. Mater. Res. 44, 65 (2014).
- [43] M. Huijben, L. W. Martin, Y.-H. Chu, M. B. Holcomb, P. Yu, G. Rijnders, D. H. A. Blank, and R. Ramesh, Critical thickness and orbital ordering in ultrathin La_{0.7}Sr_{0.3}MnO₃ films, Phys. Rev. B 78, 094413 (2008).
- [44] M. A. Torija, M. Sharma, J. Gazquez, M. Varela, C. He, J. Schmitt, J. A. Borchers, M. Laver, S. El-Khatib, and C. Leighton, Chemically driven nanoscopic magnetic phase separation at the SrTiO₃(001)/La_{1-x}Sr_xCoO₃ interface, Adv. Mater. 23, 2711 (2011).
- [45] S. Stemmer and A. J. Millis, Quantum confinement in oxide quantum wells, MRS Bull. 38, 1032 (2013).
- [46] D. G. Schlom, L.-Q. Chen, X. Pan, A. Schmehl, and M. A. Zurbuchen, A thin film approach to engineering functionality into oxides, J. Am. Ceram. Soc. 91, 2429 (2008).
- [47] J. M. Rondinelli and N. A. Spaldin, Structure and properties of functional oxide thin films: Insights from electronic-structure calculations, Adv. Mater. 23, 3363 (2011).
- [48] J. Walter, S. Bose, M. Cabero, G. Yu, M. Greven, M. Varela, and C. Leighton, Perpendicular magnetic anisotropy via strain-engineered oxygen vacancy ordering in epitaxial $La_{1-x}Sr_xCoO_{3-\delta}$, Phys. Rev. Mater. **2**, 111404(R) (2018).
- [49] J. Walter, S. Bose, M. Cabero, M. Varela, and C. Leighton, Giant anisotropic magnetoresistance in oxygen-vacancyordered epitaxial La_{0.5}Sr_{0.5}CoO_{3-δ} films, Phys. Rev. Mater. 4, 091401(R) (2020).
- [50] V. Chaturvedi, W. M. Postiglione, R. D. Chakraborty, B. Yu, W. Tabiś, S. Hameed, N. Biniskos, A. Jacobson, Z. Zhang, H. Zhou *et al.*, Doping- and strain-dependent electrolytegate-induced perovskite to brownmillerite transformation in epitaxial La_{1-x}Sr_xCoO_{3- δ} films, ACS Appl. Mater. Interfaces **13**, 51205 (2021).
- [51] M. Björck and G. Andersson, GenX: An extensible x-ray reflectivity refinement program utilizing differential evolution, J. Appl. Crystallogr. 40, 1174 (2007).
- [52] A. G. Zabrodskii, The Coulomb gap: The view of an experimenter, Philos. Mag. B 81, 1131 (2001).

- [53] J. W. Matthews and A. E. Blakeslee, Defects in epitaxial multilayers: I. Misfit dislocations, J. Cryst. Growth 27, 118 (1974).
- [54] J. W. Matthews, Coherent Interfaces and Misfit Dislocations, in *Epitaxial Growth: Part B*, edited by J. W. Matthews (Academic Press, New York, 1975), p. 559.
- [55] E. A. Fitzgerald, Dislocations in strained-layer epitaxy: Theory, experiment, and applications, Mater. Sci. Rep. 7, 87 (1991).
- [56] D. J. Dunstan, S. Young, and R. H. Dixon, Geometrical theory of critical thickness and relaxation in strained-layer growth, J. Appl. Phys. **70**, 3038 (1991).
- [57] S. C. Jain, A. H. Harker, and R. A. Cowley, Misfit strain and misfit dislocations in lattice mismatched epitaxial layers and other systems, Philos. Mag. A 75, 1461 (1997).
- [58] See Supplemental Material at http://link.aps.org/ supplemental/10.1103/PhysRevMaterials.7.024415 for additional transport data analysis and parameters extracted from GIXR fitting.
- [59] R. D. B. Fraser and E. Suzuki, Resolution of overlapping bands: Functions for simulating band shapes, Anal. Chem. 41, 37 (1969).
- [60] D. Fuchs, E. Arac, C. Pinta, S. Schuppler, R. Schneider, and H. V. Löhneysen, Tuning the magnetic properties of LaCoO₃ thin films by epitaxial strain, Phys. Rev. B 77, 014434 (2008).
- [61] V. Chaturvedi, J. Walter, A. Paul, A. Grutter, B. Kirby, J. S. Jeong, H. Zhou, Z. Zhang, B. Yu, M. Greven *et al.*, Straininduced majority carrier inversion in ferromagnetic epitaxial LaCoO_{3- δ} thin films, Phys. Rev. Mater. 4, 034403 (2020).
- [62] U. Pietsch, V. Holý, and T. Baumbach, *High-Resolution X-Ray Scattering*, 2nd ed. (Springer-Verlag, New York, 2004).
- [63] J. S. Speck and W. Pompe, Domain configurations due to multiple misfit relaxation mechanisms in epitaxial ferroelectric thin films. I. theory, J. Appl. Phys. 76, 466 (1994).
- [64] D. J. Dunstan, Strain and strain relaxation in semiconductors, J. Mater. Sci.: Mater. Electron. 8, 337 (1997).
- [65] T. Suzuki, Y. Nishi, and M. Fujimoto, Analysis of misfit relaxation in heteroepitaxial BaTiO₃ thin films, Philos. Mag. A 79, 2461 (1999).
- [66] T. Wang, K. Ganguly, P. Marshall, P. Xu, and B. Jalan, Critical thickness and strain relaxation in molecular beam epitaxygrown SrTiO₃ films, Appl. Phys. Lett. **103**, 212904 (2013).
- [67] S. Gariglio, N. Stucki, J.-M. Triscone, and G. Triscone, Strain relaxation and critical temperature in epitaxial ferroelectric Pb(Zr_{0.20}Ti_{0.80})O₃ thin films, Appl. Phys. Lett. **90**, 202905 (2007).
- [68] G. H. Lee, B. C. Shin, and I. S. Kim, Critical thickness of BaTiO₃ film on SrTiO₃(001) evaluated by reflection high-energy electron diffraction, Mater. Lett. 50, 134 (2001).
- [69] C. Merckling, M. El-Kazzi, G. Delhaye, V. Favre-Nicolin, Y. Robach, M. Gendry, G. Grenet, G. Saint-Girons, and G. Hollinger, Strain relaxation and critical thickness for epitaxial LaAlO₃ thin films grown on SrTiO₃(001) substrates by molecular beam epitaxy, J. Cryst. Growth **306**, 47 (2007).
- [70] A. Prakash, J. Dewey, H. Yun, J. S. Jeong, K. A. Mkhoyan, and B. Jalan, Hybrid molecular beam epitaxy for the growth of stoichiometric BaSnO₃, J. Vac. Sci. Technol. A 33, 060608 (2015).

- [71] S. J. Pennycook, H. Zhou, M. F. Chisholm, A. Y. Borisevich, M. Varela, J. Gazquez, T. J. Pennycook, and J. Narayan, Misfit accommodation in oxide thin film heterostructures, Acta Mater. 61, 2725 (2013).
- [72] B. P. Uberuaga, P. P. Dholabhai, G. Pilania, and A. Chen, Semicoherent oxide heterointerfaces: Structure, properties, and implications, APL Mater. 7, 100904 (2019).
- [73] F. Sánchez, M. V. Garcia-Cuenca, C. Ferrater, M. Varela, G. Herranz, B. Martinez, and J. Fontcuberta, Transition from three- to two-dimensional growth in strained SrRuO₃ films on SrTiO₃(001), Appl. Phys. Lett. 83, 902 (2003).
- [74] H. P. Sun, W. Tian, X. Q. Pan, J. H. Haeni, and D. G. Schlom, Evolution of dislocation arrays in epitaxial BaTiO₃ thin films grown on (100) SrTiO₃, Appl. Phys. Lett. 84, 3298 (2004).
- [75] J. Santiso, J. Roqueta, N. Bagués, C. Frontera, Z. Konstantinovic, Q. Lu, B. Yildiz, B. Martínez, A. Pomar, L. Balcells *et al.*, Self-arranged misfit dislocation network formation upon strain release in La_{0.7}Sr_{0.3}MnO₃/LaAlO₃(100) epitaxial films under compressive strain, ACS Appl. Mater. Interfaces **8**, 16823 (2016).
- [76] H. Zhou, M. F. Chisholm, P. Pant, H. J. Chang, J. Gazquez, S. J. Pennycook, and J. Narayan, Atomic structure of misfit dislocations in nonpolar ZnO/Al₂O₃ heterostructures, Appl. Phys. Lett. **97**, 121914 (2010).
- [77] J. W. Matthews, Defects associated with the accommodation of misfit between crystals, J. Vac. Sci. Technol. 12, 126 (1975).
- [78] J. W. Matthews, A. E. Blakeslee, and S. Mader, Use of misfit strain to remove dislocations from epitaxial thin films, Thin. Solid. Films 33, 253 (1976).
- [79] D. J. Eaglesham, E. P. Kvam, D. M. Maher, C. J. Humphreys, and J. C. Bean, Dislocation nucleation near the critical thickness in GeSi/Si strained layers, Philos. Mag. A 59, 1059 (1989).
- [80] L. B. Freund, Dislocation mechanisms of relaxation in strained epitaxial films, MRS Bull. 17, 52 (1992).
- [81] D. O. Klenov, W. Donner, B. Foran, and S. Stemmer, Impact of stress on oxygen vacancy ordering in epitaxial $(La_{0.5}Sr_{0.5})CoO_{3-\delta}$ thin films, Appl. Phys. Lett. **82**, 3427 (2003).
- [82] J. Gazquez, S. Bose, M. Sharma, M. A. Torija, S. J. Pennycook, C. Leighton, and M. Varela, Lattice mismatch accommodation via oxygen vacancy ordering in epitaxial La_{0.5}Sr_{0.5}CoO_{3-δ} thin films, APL Mater. 1, 012105 (2013).
- [83] T. Suzuki, Y. Nishi, and M. Fujimoto, Defect structure in homoepitaxial non-stoichiometric strontium titanate thin films, Philos. Mag. A 80, 621 (2000).
- [84] C. M. Brooks, L. F. Kourkoutis, T. Heeg, J. Schubert, D. A. Muller, and D. G. Schlom, Growth of homoepitaxial SrTiO₃ thin films by molecular-beam epitaxy, Appl. Phys. Lett. 94, 162905 (2009).
- [85] E. Breckenfeld, A. B. Shah, and L. W. Martin, Strain evolution in non-stoichiometric heteroepitaxial thin-film perovskites, J. Mater. Chem. C 1, 8052 (2013).
- [86] W. Y. Wang, Y. L. Tang, Y. L. Zhu, J. Suriyaprakash, Y. B. Xu, Y. Liu, B. Gao, S.-W. Cheong, and X. L. Ma, Atomic mapping of Ruddlesden-Popper faults in transparent conducting BaSnO₃-based thin films, Sci. Rep. 5, 16097 (2015).
- [87] H. Paik, Z. Chen, E. Lochocki, A. Seidner H., A. Verma, N. Tanen, J. Park, M. Uchida, S. Shang, B.-C. Zhou

et al., Adsorption-controlled growth of La-Doped BaSnO₃ by molecular-beam epitaxy, APL Mater. **5**, 116107 (2017).

- [88] M. A. Zurbuchen, W. Tian, X. Q. Pan, D. Fong, S. K. Streiffer, M. E. Hawley, J. Lettieri, Y. Jia, G. Asayama, S. J. Fulk *et al.*, Morphology, structure, and nucleation of out-of-phase boundaries (OPBs) in epitaxial films of layered oxides, J. Mater. Res. 22, 1439 (2007).
- [89] G. Catalan, R. M. Bowman, and J. M. Gregg, Metal-insulator transitions in NdNiO₃ thin films, Phys. Rev. B 62, 7892 (2000).
- [90] A. H. Cottrell and B. A. Bilby, Dislocation theory of yielding and strain ageing of iron, Proc. Phys. Soc. A 62, 49 (1949).
- [91] M. A. Meyers and K. K. Chawla, *Mechanical Behavior of Materials*, 2nd ed. (Cambridge University Press, Cambridge, 2008).
- [92] M. Arredondo, Q. M. Ramasse, M. Weyland, R. Mahjoub, I. Vrejoiu, D. Hesse, N. D. Browning, M. Alexe, P. Munroe, and V. Nagarajan, Direct evidence for cation non-stoichiometry and Cottrell atmospheres around dislocation cores in functional oxide interfaces, Adv. Mater. 22, 2430 (2010).
- [93] J. M. Millunchick, R. D. Twesten, S. R. Lee, D. M. Follstaedt, E. D. Jones, S. P. Ahrenkiel, Y. Zhang, H. M. Cheong, and A. Mascarenhas, Spontaneous lateral composition modulation in III-V semiconductor alloys, MRS Bull. 22, 38 (1997).
- [94] A. Zunger and S. Mahajan, Atomic ordering and phase separation in epitaxial III-V alloys, in *Handbook on Semiconductors: Materials, Properties and Preparation*, (Elsevier, Amsterdam, 1994), Vol. 3b, p. 1399.
- [95] B. J. Spencer, P. W. Voorhees, and J. Tersoff, Morphological instability theory for strained alloy film growth: The effect of compositional stresses and species-dependent surface mobilities on ripple formation during epitaxial film deposition, Phys. Rev. B 64, 235318 (2001).
- [96] I. P. Ipatova, V. G. Malyshkin, A. A. Maradudin, V. A. Shchukin, and R. F. Wallis, Kinetic instability of semiconductor alloy growth, Phys. Rev. B 57, 12968 (1998).
- [97] R. D. Shannon, Revised effective ionic radii and systematic studies of interatomic distances in halides and chalcogenides, Acta Cryst. A 32, 751 (1976).
- [98] H. Yun, A. Prakash, T. Birol, B. Jalan, and K. A. Mkhoyan, Dopant segregation inside and outside dislocation cores in perovskite BaSnO₃ and reconstruction of the local atomic and electronic structures, Nano Lett. **21**, 4357 (2021).
- [99] M. Minohara, M. Kitamura, H. Wadati, H. Nakao, R. Kumai, Y. Murakami, and H. Kumigashira, Thickness-dependent physical properties of La_{1/3}Sr_{2/3}FeO₃ thin films grown on SrTiO₃(001) and (111) substrates, J. Appl. Phys. **120**, 025303 (2016).
- [100] J. Y. Zhang, H. Kim, E. Mikheev, A. J. Hauser, and S. Stemmer, Key role of lattice symmetry in the metal-insulator transition of NdNiO₃ films, Sci. Rep. 6, 23652 (2016).
- [101] H. Zhou, M. F. Chisholm, T.-H. Yang, S. J. Pennycook, and J. Narayan, Role of interfacial transition layers in VO₂/Al₂O₃ heterostructures, J. Appl. Phys. **110**, 073515 (2011).
- [102] F. J. Wong, Y. Zhou, and S. Ramanathan, Epitaxial variants of VO₂ thin films on complex oxide single crystal substrates with 3*m* surface symmetry, J. Cryst. Growth **364**, 74 (2013).
- [103] N. F. Quackenbush, J. W. Tashman, J. A. Mundy, S. Sallis, H. Paik, R. Misra, J. A. Moyer, J.-H. Guo, D. A. Fischer, J. C. Woicik *et al.*, Nature of the metal insulator transition

in ultrathin epitaxial vanadium dioxide, Nano Lett. 13, 4857 (2013).

[104] H. Paik, J. A. Moyer, T. Spila, J. W. Tashman, J. A. Mundy, E. Freeman, N. Shukla, J. M. Lapano, R. Engel-Herbert, W. Zander *et al.*, Transport properties of ultra-thin VO_2 films on (001) TiO₂ grown by reactive molecular-beam epitaxy, Appl. Phys. Lett. **107**, 163101 (2015).